

## Electronic Acknowledgement Receipt

<b>EFS ID:</b>	7856162
<b>Application Number:</b>	10661917
<b>International Application Number:</b>	
<b>Confirmation Number:</b>	8346
<b>Title of Invention:</b>	Systems and methods for mastering microstructures through a substrate using negative photoresist and microstructure masters so produced
<b>First Named Inventor/Applicant Name:</b>	Robert P. Freese
<b>Customer Number:</b>	20792
<b>Filer:</b>	Mitchell S. Bigel/Susan Freedman
<b>Filer Authorized By:</b>	Mitchell S. Bigel
<b>Attorney Docket Number:</b>	9409-3
<b>Receipt Date:</b>	21-JUN-2010
<b>Filing Date:</b>	11-SEP-2003
<b>Time Stamp:</b>	15:25:14
<b>Application Type:</b>	Utility under 35 USC 111(a)

### Payment information:

Submitted with Payment	no
------------------------	----

### File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/Message Digest	Multi Part/.zip	Pages (if appl.)
1		9409-3_IDS_062110.pdf	333245 e4f59615825013e8090fb5ff8005d7c3 6ece	yes	3

Multipart Description/PDF files in .zip description							
Document Description			Start	End			
Transmittal Letter			1	2			
Information Disclosure Statement (IDS) Filed (SB/08)			3	3			
<b>Warnings:</b>							
<b>Information:</b>							
2	NPL Documents	9409-3_JPOA.pdf	469603 ec72139d4bfc5f513b541556c0fc10b8d0f 1d79a	no	5		
<b>Warnings:</b>							
<b>Information:</b>							
3	Foreign Reference	9409-3_JP2004280017A.pdf	1652777 edc13b95faac718961fb0a00a08d1a4b784 8c3	no	19		
<b>Warnings:</b>							
<b>Information:</b>							
4	Foreign Reference	9409-3_JP2000103062A.pdf	7353943 ed807208bc700c99e0ad99b0e0654fe748d 294b7	no	46		
<b>Warnings:</b>							
<b>Information:</b>							
5	Foreign Reference	9409-3_2001056569A.pdf	1904723 10ab2af97e5597a082849901cfbd4ca29e7 a295	no	16		
<b>Warnings:</b>							
<b>Information:</b>							
6	Foreign Reference	9409-3_WO0044161A1.pdf	2130313 #9e14fa3drb7411b922caaa5b3c51c768 0416a	no	26		
<b>Warnings:</b>							
<b>Information:</b>							
<b>Total Files Size (in bytes):</b>				13844604			

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

**New Applications Under 35 U.S.C. 111**

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

**National Stage of an International Application under 35 U.S.C. 371**

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

**New International Application Filed with the USPTO as a Receiving Office**

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.